

03-12-01

Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

Correspondence Address:

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Date: March 9, 2001

Attorney Docket No.: 450100-03058

ASSISTANT COMMISSIONER FOR PATENTS

Box Patent Application

Washington, D.C. 20231

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Akira NONAKA

entitled:

DATA DISTRIBUTION SYSTEM AND METHOD OF SAME, DATA PROCESSING APPARATUS AND METHOD OF SAME, AND DATA RECORDING MEDIUM

The following are enclosed:

- ☒ Specification ( 60 pages)
- ☒ 37 Sheet(s) of Drawings
- ☒ 49 Claim(s) (including 17 independent claim(s))
- ☐ This application contains a multiple dependent claim

- ☒ Our check for \$ 2352.00, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$710.00 (\$355.00)	\$ 710.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each: 29	522.00
Number of Independent Claims in excess of 3 at \$80.00 (\$40.00) each: 14	1120.00
Multiple Dependent Claim Fee at \$270.00 (\$135.00)	-0-
Total Filing Fee	2352.00
Assignment Recording Fee \$40.00	-0-

- ☒ Oath or Declaration and Power of Attorney

☒ New ☐ signed ☒ unsigned  
☐ Copy from a prior application (37 C.F.R. 1.63(d))

- ☒ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
2000-072519	10 March 2000	Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP  
Attorneys for Applicant

By: 

William S. Frommer  
Reg. No. 25,506

# FROMMER LAWRENCE & HAUG LLP

745 FIFTH AVENUE NEW YORK, NEW YORK 10151

jc929 U.S. PTO  
09/803396  
03/09/01

March 9, 2001

Assistant Commissioner for Patents  
Washington, D.C. 20231

Re: U.S. Patent Application  
Applicant: Akira NONAKA  
Our Ref.: 450100-03058

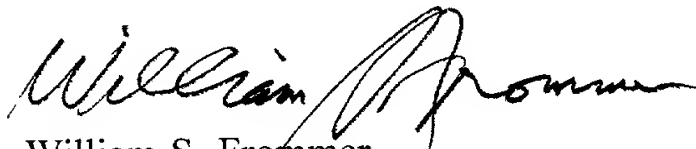
Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

William S. Frommer, Esq.  
FROMMER LAWRENCE & HAUG LLP  
745 Fifth Avenue  
New York, New York 10151

Respectfully,



William S. Frommer  
Reg. No. 25,506  
Attorney for Applicant  
Enclosures

J:\SONY\03058\53BAPUNS.EXM (WSF:sa)

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